# MULTIBAND IMAGING PHOTOMETER FOR SPITZER (MIPS) Pocket Guide

# http://ssc.spitzer.caltech.edu/mips/

## **Basic MIPS Capabilities:**

Imaging photometry at 24, 70, and 160  $\mu$ m and low resolution (R = 15 – 25) spectroscopy between 52 and 97  $\mu$ m. A fine pixel scale option at 70  $\mu$ m (no change required for the other two bands), combined with precise subpixel sampling dither patterns, allow data processing to achieve "super resolution" imaging. A cryogenic scan mirror mechanism provides freeze frame scan mapping, efficient dithering, and other instrument capabilities.

#### **MIPS Instantaneous Fields of View:**

24	ıım	5 4×5 4	arcminutes
44	мии	J.4XJ.4	arcillilluces

70  $\mu$ m 5.25×2.6 or 2.6×1.3 arcminutes 160  $\mu$ m 0.53×5.33 arcminutes (effective)

**SED Slit** 2.0×0.33 arcminutes (full wavelength coverage)

#### **Basic Sensitivities (low background):**

5 sigma in 500 seconds on source

**24 μm** 110 μJy **70 μm default** 7.2 mJy **70 μm fine** 14.4 mJy

SED 82/201/447 mJy @ 60/75/90 μm

160 μm 29 (40 w/ confusion) mJy



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#### **The MIPS Astronomical Observation Templates:**

#### **Photometry & Super Resolution**

- Telescope staring mode imaging photometry

#### **Scan Mapping**

- Freeze frame mapping in all three bands with constant telescope slewing

#### **Spectral Energy Distribution (SED)**

- Low resolution (R = 15 - 25) spectroscopy over 52 to 97  $\mu$ m

#### **Total Power Mode**

- Zero level brightness of very extended emission

## **The MIPS Detector Arrays:**

24 μm Si:As (IBC)

128x128 pixels; 2.55" 4.7 µm bandwidth

**70 μm** Ge:Ga

32x32 pixels; 5.3" or 9.96"

19 µm bandwidth

SED R = 15 - 25 (9.8" pixels)

160 µm Stressed Ge:Ga

2x20 pixels; 16.0"x18.0"

35 µm bandwidth

#### **Saturation Limits:**

Point source in 1 second (Jy); Extended source in 10 seconds (MJy/ster)

<u>Band</u>	Point Source	<u>Extended</u>	
24 μm	4.1	260	
70 µm (default)	23	101	
70 µm (fine)	57	292	
SED @ 60,75,90µm	250/290/1000	1087/1261/4350	
160 um	3	20	



